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#10/FDS
6/21/02
Docket No. 0756-2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Taketomi ASAMI et al.

Serial No. 09/842,315

Filed: 04/26/2001

For: MANUFACTURING METHOD FOR
SEMICONDUCTOR DEVICE

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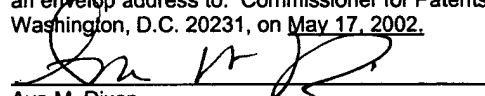
Group Art Unit: 2813

Examiner: David S. Blum

Confirmation No. 5664

CERTIFICATE OF MAILING

I hereby certify that this correspondence
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Ava M. Dixon

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

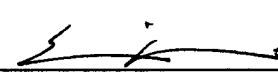
Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c)

It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,


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